



IRW

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	Confirmation No. 2087
)	
Ching-Hsiang Hsu et al.)	
)	
Application No.: 10/750,887)	Group Art Unit: 1638
)	
Filed: January 5, 2004)	Examiner: Bui, Phuong T.
)	
For: PROCESS FOR PRODUCING DUST MITE))	
ALLERGEN)	Docket No: 001409.00008

RESPONSE TO RESTRICTION REQUIREMENT

Commissioner of Patents
c/o Customer Service Window
Randolph Building
401 Dulany Street
Alexandria, VA 22314

Sir:

In response to the Office Action mailed December 29, 2005, Applicants elect for prosecution in this application Group III drawn to a process for producing a dust mite allergen via ZYMV . This Group encompasses claims 1-28.

No additional fee is believed due in connection with this response. However, should the Patent and Trademark Office determine that a fee is required, please charge our Deposit Account No. 19-0733.

Respectfully submitted,

Date: January 25, 2006

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